



\$2814

AMENDMENT TRANSMITTAL LETTER					Docket No. TESSERA 3.0-085 CONT DIV
09/732,821		Filing Date December 8, 2000		Examiner A. Chambliss	Art Unit
licant(s): Joseph Fjelstad		December 6, 2000		A. Chambiis	s 2814
	pn rjeistad				
ntion: METHC	DS FOR MAN	UFACTURING	RESISTOR	S USING A SACRIF	ICAL LAYER
	TC	THE COMMI	SSIONER FO	OR PATENTS	
nsmitted herev	vith is an amen	dment in the a	bove-identifie	ed application.	
fee has been	calculated and	l is transmitted	as shown be	low.	
	Claims	CLAIM Highest	S AS AMENI	DED	
	Remaining After Amendment	Number Previously Paid	Number Extra Claims Present	Rate	
otal Claims	48	- 48 =		×	0.00
ndependent laims	6	- 6 =		×	0.00
lultiple Depend	ent Claims (ch	eck if applicabl	e)		
-					
Other fee (pleas	e specify):				
OTAL ADDITI	ONAL FEE FO	R THIS AMEN	IDMENT:		0.00
Large Entity				Small Entity	
No additiona	I fee is required	d for this amen	dment.		
	ge Deposit Acc			the amount of \$	•
A check in th	e amount of \$		to cover	the filing fee is enclo	osed.
				credit Deposit Accou	unt No. 12-1095
	below. A dupl		nis sheet is er	nclosed.	
	ny overpaymen				
x Charge a	ny additional filir	ng or application	processing fe	es required under 37 (CFR 1.16 and 1.17.
	_(/~			Dated:	May 14, 2002
Marcus J. Millet	,				
ttorney Reg. N					
ERNER, DAVII 00 South Aven	D, LITTENBER lue West	kg, KRUMHOL	Z & MENTLIF	K, LLP	
Vestfield, New					
908) 518-6450					
					٠,

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on the date shown below.

Dated: May 14, 2002

Signature:

(Marcus J. Miller

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